O LTST OF ART CITED BY APPLICANT (PTO-1449)				ATTY, DOCKET NO. P-0769		APPLN. SERIAL NO. 10/572,954			
				APPLICANT(S) Min-Woo LEE					
				FILING DATE March 21, 2006		GROUP 3749 Io Be Assigned			
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EXAMINER	/Todd D. Jacobs/				ATE CONSIDERED 04/21/2009				

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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